

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/720,147	ISHIKAWA ET AL.
	Examiner	Art Unit
	Hong C. Kim	2185

SEARCHED			
Class	Subclass	Date	Examiner
711	2 102	6/5/06	JLH
	104		1
	154		
	170		
	202		
710	38		
	40		
	316		
	317		
369	44.11		
	47.1	✓	✓

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
See Attachment		6/5/06	JLR